



Docket No. 740819-617

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Kenji ORITA et al.) Group Art Unit: 2814
Serial No. 09/986,997) Examiner: Long Pham
Filed: November 13, 2001)
For: METHOD OF FABRICATING SEMICONDUCTOR) Confirmation No.: 6386
DEVICE HAVING GROUP III NITRIDE)

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at (703) 872-9306 on March 3, 2004.

Angelique H. Graham
Angelique Graham

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1540
Alexandria, Virginia 22313-1450

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Sir:

In response to the non-final Office Action mailed December 3, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.

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